



Docket No.: MRE-0028

6/Election
7.8.02
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yun Hyung YI

Serial No.: 09/586,797

Confirm. No.: 7980

Filed: June 5, 2000

For: A SURFACE MOUNTING APPARATUS AND A SURFACE MOUNTING
METHOD

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: Group Art Unit: 3729
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: Examiner: T. Nguyen
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TC 3700 MAIL ROOM

REPLY TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents
Washington, D. C. 20231

Sir:

In response to the Restriction Requirement dated June 4, 2002, Applicant hereby elects Group II, claims 7 and 12, with traverse.

It is respectfully submitted that the subject matter of each of the designated inventions is sufficiently related that a thorough search for the subject matter of each of the designated inventions would encompass a search for the subject matter of the remaining designated inventions. Thus, it is respectfully submitted that the search and examination of the entire application could be made without serious burden. See MPEP §803 in which it states that "if the search and examination of an entire application can be made without serious burden, the Examiner must examine it on the merits, even though it includes claims to distinct or independent inventions." It is respectfully submitted that this policy should apply in the present


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application in order to avoid unnecessary delay and expense to Applicant and duplicative examination by the U.S. Patent and Trademark Office.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 16-0607 and please credit any excess fees to such deposit account.

Respectfully submitted,
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